



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

April 28, 2025

IGI Report Number **LG700575786**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **7.53 X 5.41 X 3.66 MM**

GRADING RESULTS

Carat Weight **1.50 CARAT**

Color Grade **D**

Clarity Grade **VS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

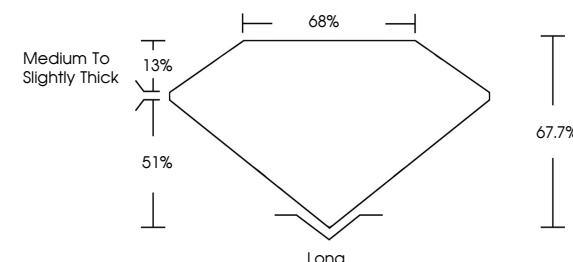
Symmetry **EXCELLENT**

Fluorescence **NONE**

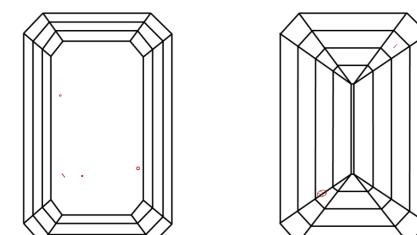
Inscription(s) **IGI LG700575786**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

www.igi.org

LG700575786
Report verification at igi.org

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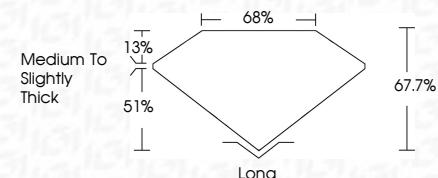
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April 28, 2025	IGI Report No LG700575786	1.50 CARAT	D	VS 2	67.7%	68%	Medium To Slightly Thick	Long	EXCELLENT	EXCELLENT	NONE	IGI LG700575786
		7.53 X 5.41 X 3.66 MM										
		Carat Weight		Color Grade		Clarity Grade		Depth		Table Grade		
		Cut		Polish		Symmetry		Fluorescence		Inscription(s)		

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